

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: MAYUZUMI

FILED: December 20, 2001

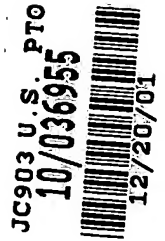
FOR: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

DOCKET: NEC 01FN061

BOX PATENT APPLICATION

Assistant Commissioner for Patents

Washington, D.C. 20231



#3 / ISS
2-13-02
R. Stok

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicant hereby attaches U.S. Patent Office Form PTOL-1449, including a copy of the prior art reference listed therein together with the English language abstract. This reference is discussed in the specification. The claims in the present application are believed to be patentably distinguished over this reference.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(a). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(a) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,

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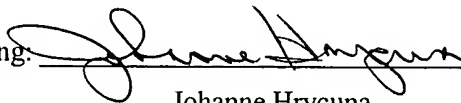
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